

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of:  
Hisao Sato et al.

Application No.: 10/516,703

Confirmation No.: 6746

Filed: December 2, 2004

Art Unit: 2826

For: GALLIUM NITRIDE COMPOUND  
SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD

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Examiner: T. N. Tran

**REPLY UNDER 37 CFR §1.116**

MS: AFTER FINAL  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated September 12, 2007, please reconsider this application in view of the following.